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Docket No. 0756-2149✓

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of: )

Hisashi OHTANI et al.✓ )

Serial No. Unassigned 09/593765✓ )

Filed: 06/14/2000✓ )

For: METHOD FOR MANUFACTURING )

A SEMICONDUCTOR DEVICE )

Art Unit: Unassigned

Examiner: Unassigned

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12-13-00  
#3 IDS  
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## CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on 7/21/2000.

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents

Washington, D.C. 20231

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Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application. Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Japanese Patent Laid-Open No. 3-22540 was filed June 14, 2000. A full English translation is submitted herewith.

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380. A duplicate copy of this sheet is attached.



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Respectfully submitted,

A handwritten signature, likely of Eric J. Robinson, written in black ink.

Eric J. Robinson  
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